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AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE -  
EXAMINING GROUP 2813

Box AF  
Assistant Commissioner for Patents  
Washington, D.C. 20231

IC 2800 MAIL ROOM

PATENT  
Attorney Docket No.: 018419-008320US

On February 24, 2003

TOWNSEND and TOWNSEND and CREW LLP

By: [Signature]

#14/Amend Group  
3/12/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Kang et al.

Application No.: 09/893,340

Filed: June 26, 2001

For: SURFACE FINISHING OF SOI  
SUBSTRATES USING AN EPI  
PROCESS

Examiner: Erik J. Kielin

AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE EXAMINING  
GROUP 2813

Box AF  
Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Final Office Action mailed September 24, 2002, please amend this application as follows:

IN THE CLAIMS:

Please amend claims 29, 32-34, 36, 37, and 39 as follows.

29. (Amended) A dry method for finishing SOI substrates, said method comprising:

providing an SOI substrate comprising a cleaved surface, said cleaved surface having a first surface roughness value;

DO NOT ENTER  
CA 3/13/03